

Docket No.: 067161-0301

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Toshihiko TANAKA

Application No.: 10/551,55

Filed: October 03, 2005

Customer Number: 20277

Confirmation Number: 3832

Group Art Unit: 2812

Examiner: Not yet assigned

For: SEMICONDUCTOR DEVICE FABRICATION METHOD AND MASK PATTERN DATA

GENERATION METHOD

INFORMATION DISCLOSURE STATEMENT

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action is attached for the Examiner's information.

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Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Please recognize our Customer No. 20277 as our correspondence address.

SHEET 1 OF 1

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(PTO-1449)					FILING DATE October 03, 200	FILING DATE October 03, 2005 GROUP 2812				
			U	S. PATEN	T DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (# known)		Publication Date MM-DD-YYYY			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.